

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Prior Application: H. INAGAWA et al
Serial No. 09/604,903
Filed: June 28, 2000

Group Art Unit: 2823

Examiner: F. Toledo

For: SEMICONDUCTOR DEVICE AND METHOD FOR
FABRICATING THE SAME

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 9, 2003

Sir:

Prior to examination, please amend the above application
as follows.